



ELECTRONIC COPY

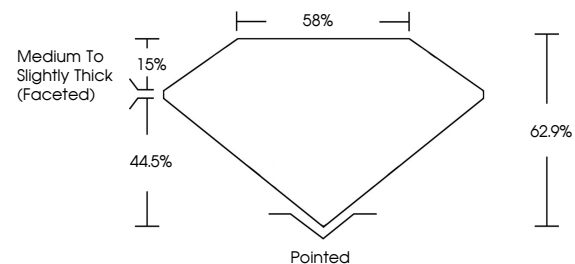
LG652400339
Report verification at igi.org



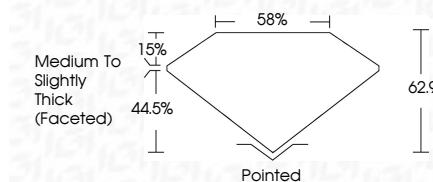
September 20, 2024
IGI Report Number **LG652400339**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **OVAL BRILLIANT**
Measurements **9.13 X 6.52 X 4.10 MM**
GRADING RESULTS
Carat Weight **1.51 CARAT**
Color Grade **E**
Clarity Grade **VVS 2**

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PROPORTIONS



Sample Image Used



ADDITIONAL GRADING INFORMATION
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG652400339**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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COLOR

| | | | | | | | | | |
|---|---|---|---|---|---|---|-------|------------|-------|
| D | E | F | G | H | I | J | Faint | Very Light | Light |
|---|---|---|---|---|---|---|-------|------------|-------|

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



IGI



September 20, 2024
IGI Report No **LG652400339**
OVAL BRILLIANT
9.13 X 6.52 X 4.10 MM
Carat Weight **1.51 CARAT**
Color Grade **E**
Clarity Grade **VVS 2**
Depth **62.9%**
Table **15%**
Girdle **Medium to Slightly Thick (Faceted)**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG652400339**

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